Docket No.: 50083-216

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Shunichi ABE, et al.

Serial No.:

Group Art Unit:

Filed: March 06, 2002

Examiner:

For:

SEMICONDUCTOR DEVICE, AND METHOD OF MANUFACTURING THE

SEMICONDUCTOR DEVICE

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Stephen A. Becker

Registration No. 26,527

600 13<sup>th</sup> Street, N.W. Washington, DC 20005-3096 (202) 756-8000 SAB:prp

**Date: March 6, 2002** Facsimile: (202) 756-8087

